

02/03/2010

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Nathan R. Brown

Serial No.: 10/715,267

Filed: November 17, 2003

For: METHODS FOR POLISHING
SEMICONDUCTOR DEVICE
STRUCTURES BY DIFFERENTIALLY
APPLYING PRESSURE TO SUBSTRATES
THAT CARRY THE SEMICONDUCTOR
DEVICE STRUCTURES

Confirmation No.: 4590

Examiner: S. Macarthur

Group Art Unit: 1792

Attorney Docket No.: 2269-4375.1US
(1999-1029.01/US)

VIA ELECTRONIC FILING
January 25, 2010

AMENDMENT UNDER 37 C.F.R. §1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Examiner:

This Amendment follows the final Office Action of November 25, 2009, the shortened statutory period for response to which expires on February 25, 2010. This Amendment is being submitted within two months of the date on which the final Office Action was mailed.

An amendment to the specification appears on page 2 of this paper;

A listing of claims, in which amendments to the claims are presented, begins on page 3 of this paper; and

Remarks start at page 8 of this paper.